

<b>Notice of References Cited</b>	Application/Control No. 10/595,272		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Caixia Lu		Art Unit 1796	Page 1 of 1

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*	B	US-2007/0293710	12-2007	Kim et al.	585/500
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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